PE 20557-4909-3



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

™ RE APPLIC∕ATION OF

KAZUNORI ITO ET AL

: EXAMINER: MCDONALD, R.

SERIAL NO: 09/498,375

FILED: FEBRUARY 4, 2000

: GROUP ART UNIT: 1753

FOR: OPTICAL DEVICE SUBSTRATE

FILM-FORMATION

APPARATUS, OPTICAL DISK SUBSTRATE FILM-FORMATION METHOD, SUBSTRATE HOLDER

MANUFACTURE METHOD,

SUBSTRATE HOLDER, OPTICAL DISK AND A PHASE-CHANGE RECORDING TYPE OF OPTICAL

DISK

AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

In response to the Official Action mailed July 31, 2002, please amend this application as follows:

IN THE SPECIFICATION

Page 10, beginning at line 12, please replace the paragraph as follows:

It is another object of the present invention to make it possible to take out and carry a substrate with a film having been formed by sputtering efficiently at a high speed in an apparatus used for forming a film by closely contacting at least one portion of a rear surface



1W.M. 11/1/02